

Raman Spectroscopy and Transmission Electron Microscopy of $\text{Si}_x\text{Ge}_{1-x}$ -Ge-Si Core-Double-Shell Nanowires

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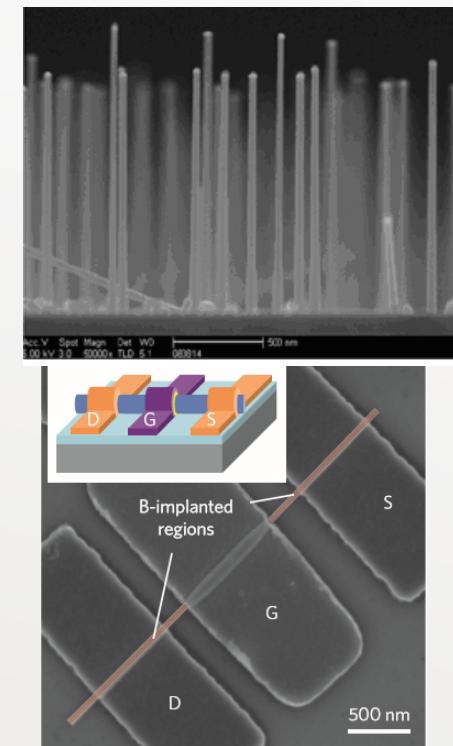
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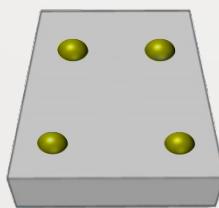
Background

- One-dimensional semiconducting nanowires (NWs)
 - Reduced dimensions and ability to engineer their electronic properties
 - Attractive for nanoscale electronics and photonics
 - Field-effect transistors
 - Solar cells

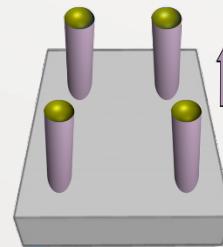


Nanowires Growth Process

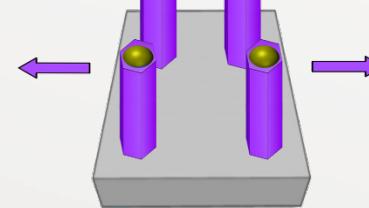
(a) Gold Catalyst



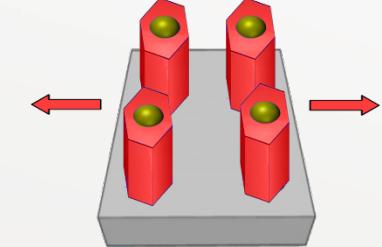
(b) VLS Core Growth



(c) CVD Shell Growth 1



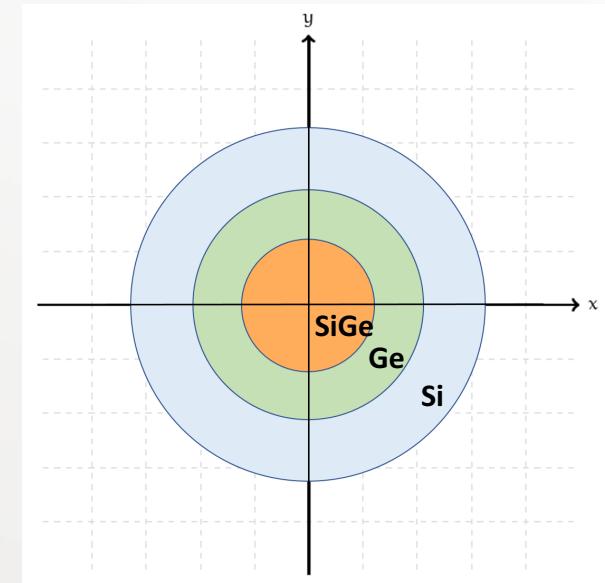
(d) CVD Shell Growth 2



Schematic of Si_xGe_{1-x} -Ge-Si core-double-shell nanowire growth. (a) Au catalyst droplets prior to growth. (b) Vapor-liquid-solid Si_xGe_{1-x} core growth. (c) and (d) ultra-high vacuum chemical vapor deposition for the Ge shell growth and Si shell growth, respectively.

Strain

- SiGe core can be used as non-planar substrate for depositing compressively strained Ge layers and tensile strained Si layers
- Strain can change the band structure and optical phonon frequencies
 - Depends on core composition, core diameter, shell thickness, and shell morphology

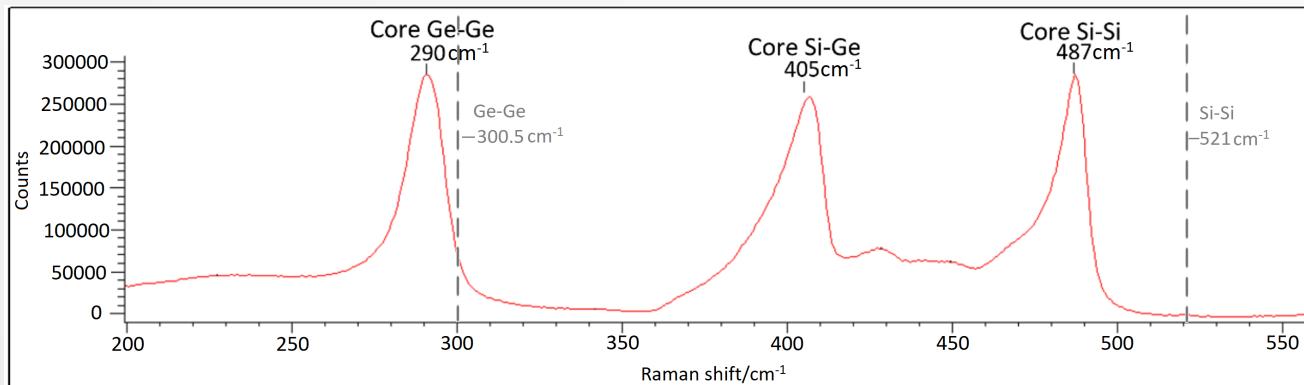


Raman Spectroscopy

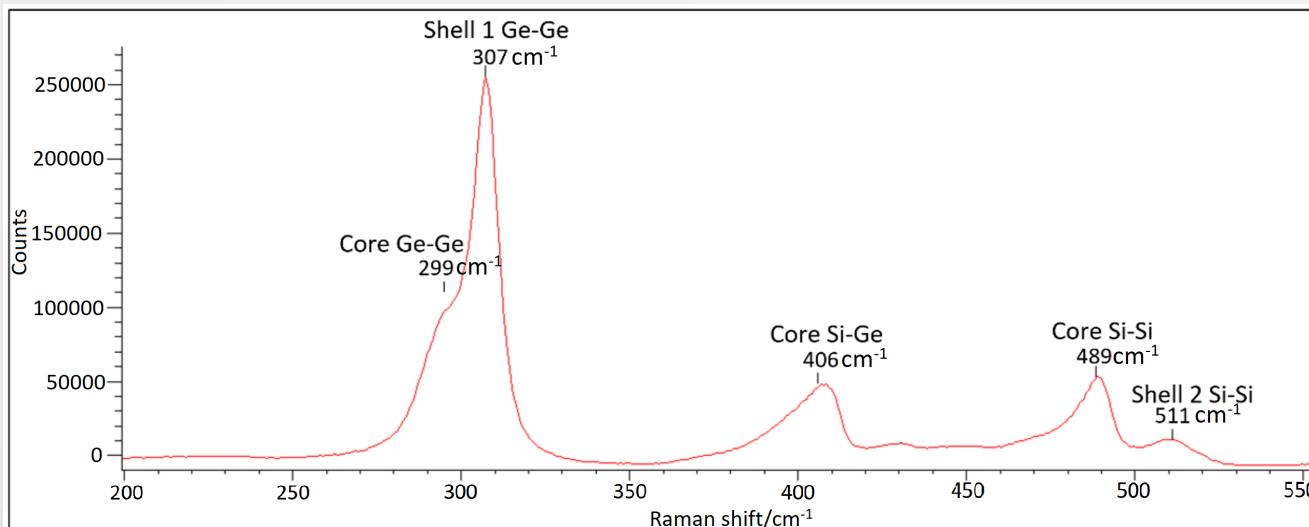
- Vibrational Spectroscopy
- Raman bands arise from specific molecular vibrations
- Used to probe strain and elemental content
- Tensile Strain in Si → red shift of Si-Si mode
- Compressive strain in Ge → blue shift of Ge-Ge mode



Raman Spectroscopy of SiGe and core-double-shell NWs



Raman spectra of Si_xGe_{1-x} NW



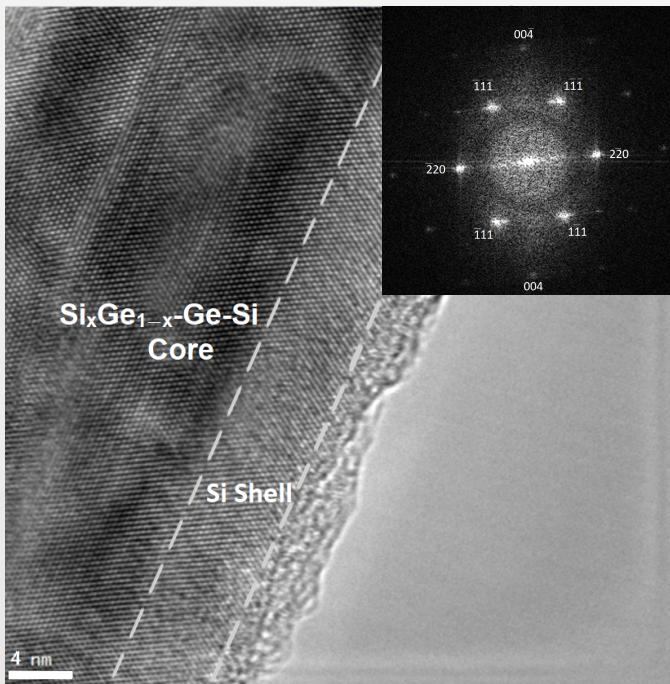
Raman spectra of Si_xGe_{1-x} -Ge-Si core-double-shell NW

Transmission Electron Microscopy (TEM)

- Microscopy technique in which a beam of electrons is transmitted through a specimen to form an image
- Planar and cross-sectional TEM are used to probe the crystal structure and measure the shell thickness.



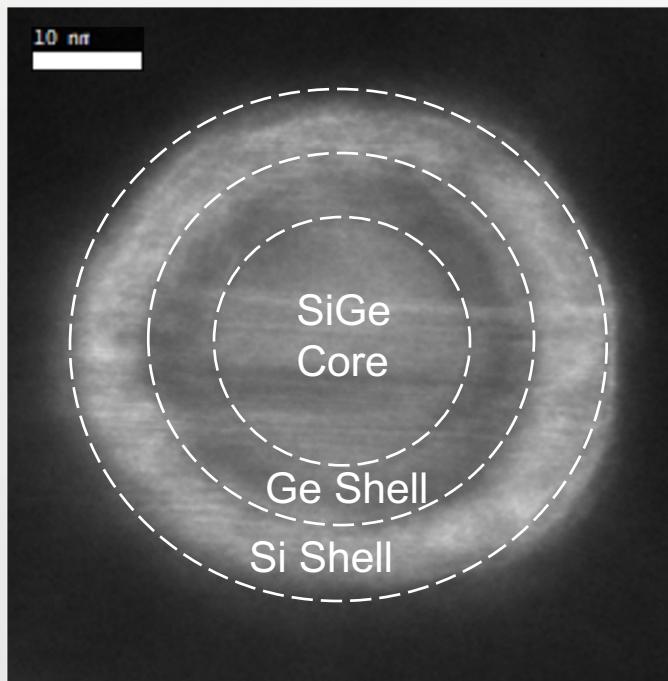
TEM of core-double-shell NWs



Planar view TEM of a $\text{Si}_x\text{Ge}_{1-x}\text{-Ge-Si}$ NW. Inset: Fourier Transforms (FFT) of the NW.

- Single crystal structure, epitaxial shell growth
- The FFT is used to determine the nanowire orientation
- The VLS growth yields NWs along the $\langle 110 \rangle$ direction

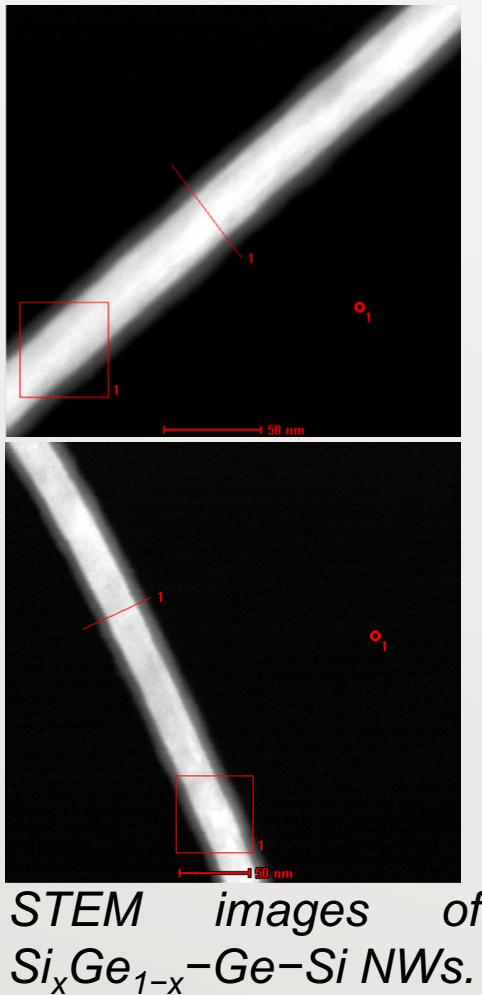
TEM of core-double-shell NWs



- Cylindrical core
- Slightly faceted shells
- Core: 10-30 nm
- Ge Shell: ~4 nm
- Si Shell: ~5 nm

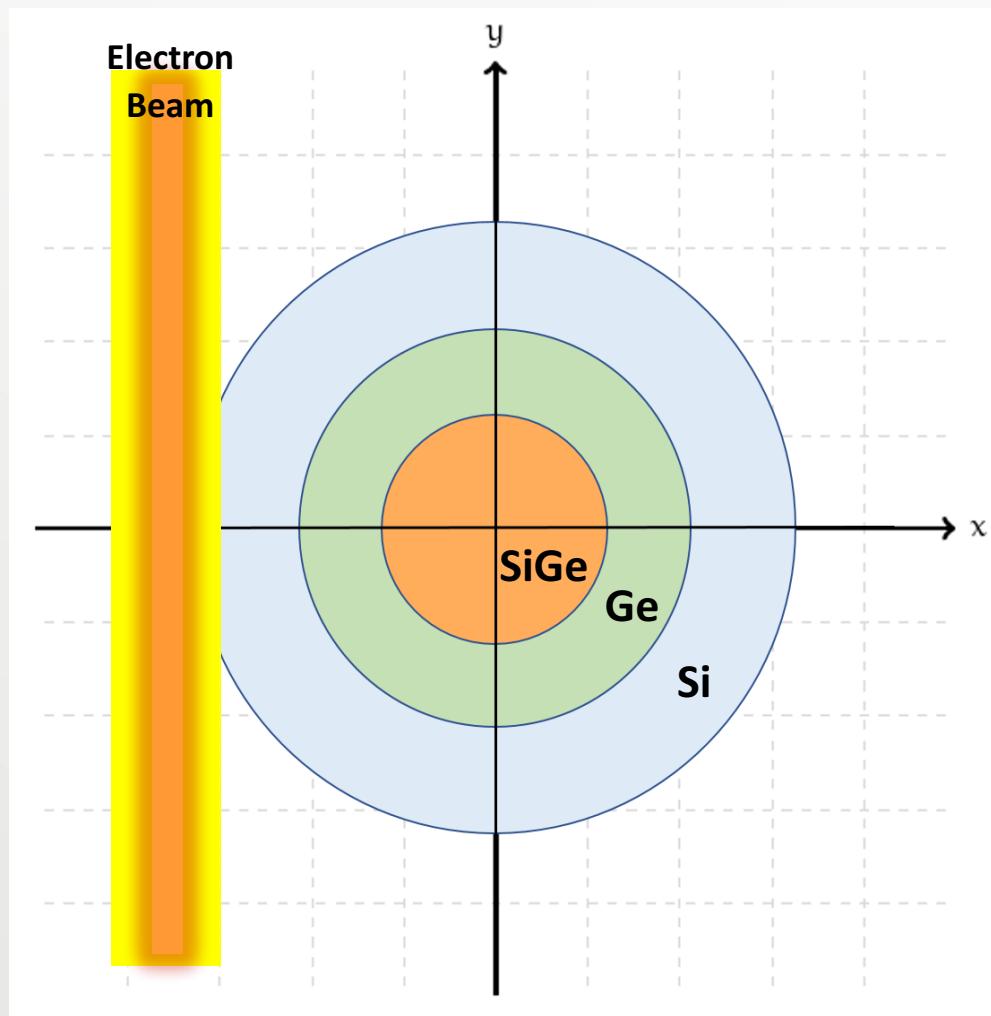
*Cross-sectional TEM of
a Si_xGe_{1-x} -Ge-Si NW.*

Energy Dispersive X-ray Spectroscopy (EDX)



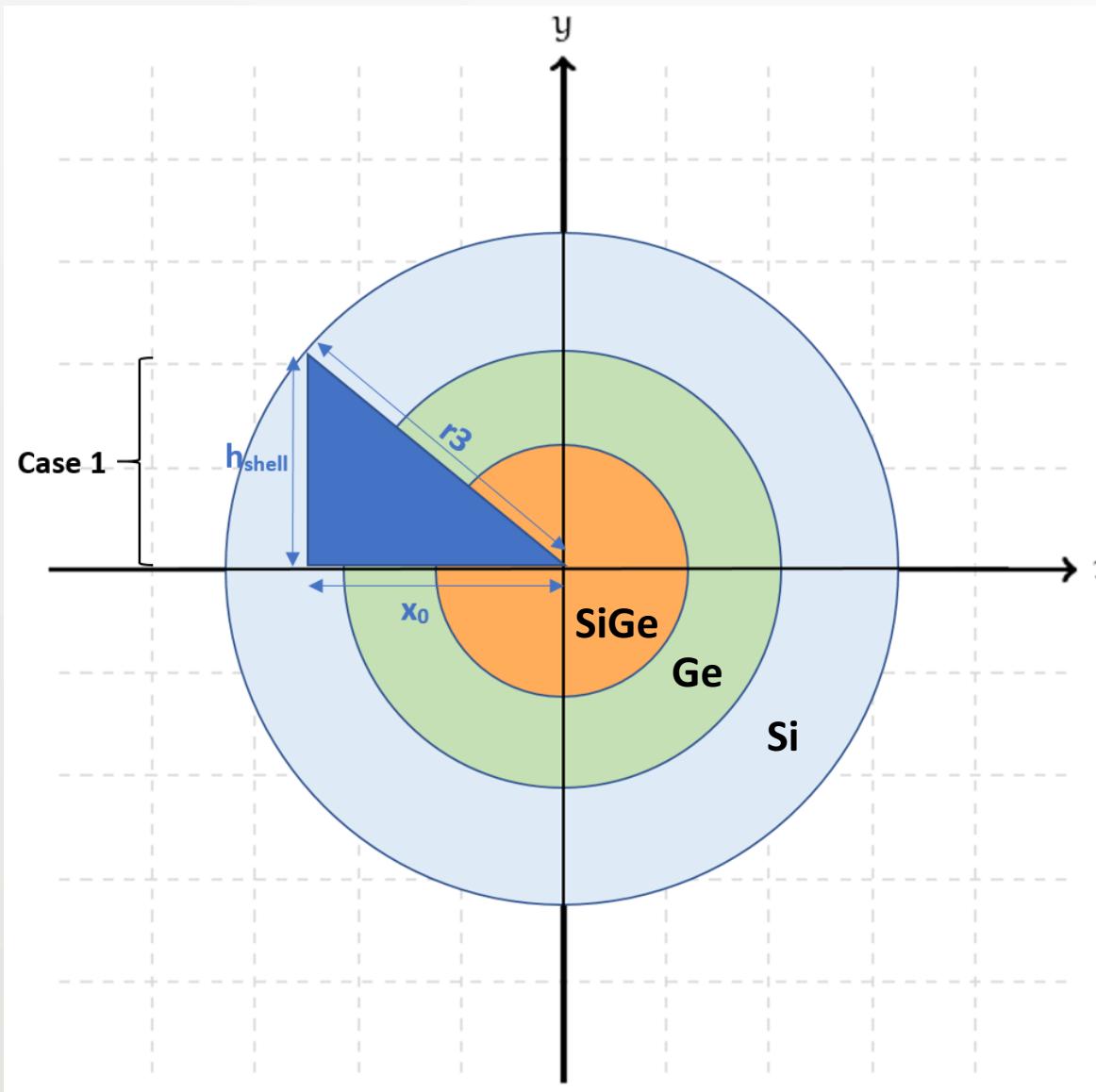
- EDX used to determine the shell thickness and core elemental composition
- Measurements acquired using line scans across the nanowires
- Si and Ge signals are fitted with a model based on the convolution of nanowire geometry and a Gaussian electron beam

EDX Linescan Across NW



Cylindrical morphology was assumed for simplicity

EDX Linescan Across Nanowire

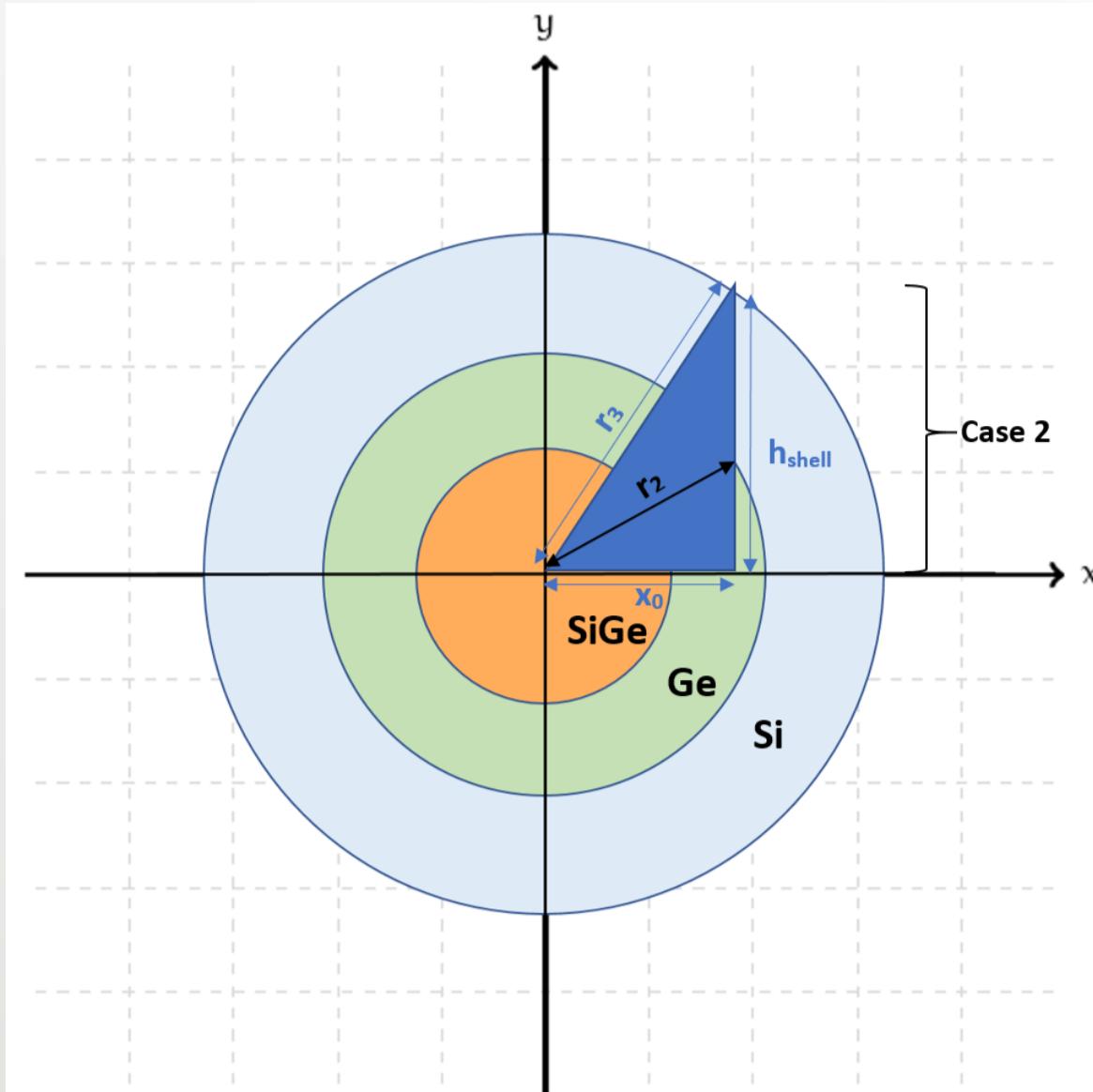


Case 1:
 $|x_0| \geq r_2 \text{ & } |x_0| \leq r_3$

$$\Psi_{\text{Si}} = 2 * \sqrt{(r_3^2 - x^2)}$$

$$\Psi_{\text{Ge}} = 0$$

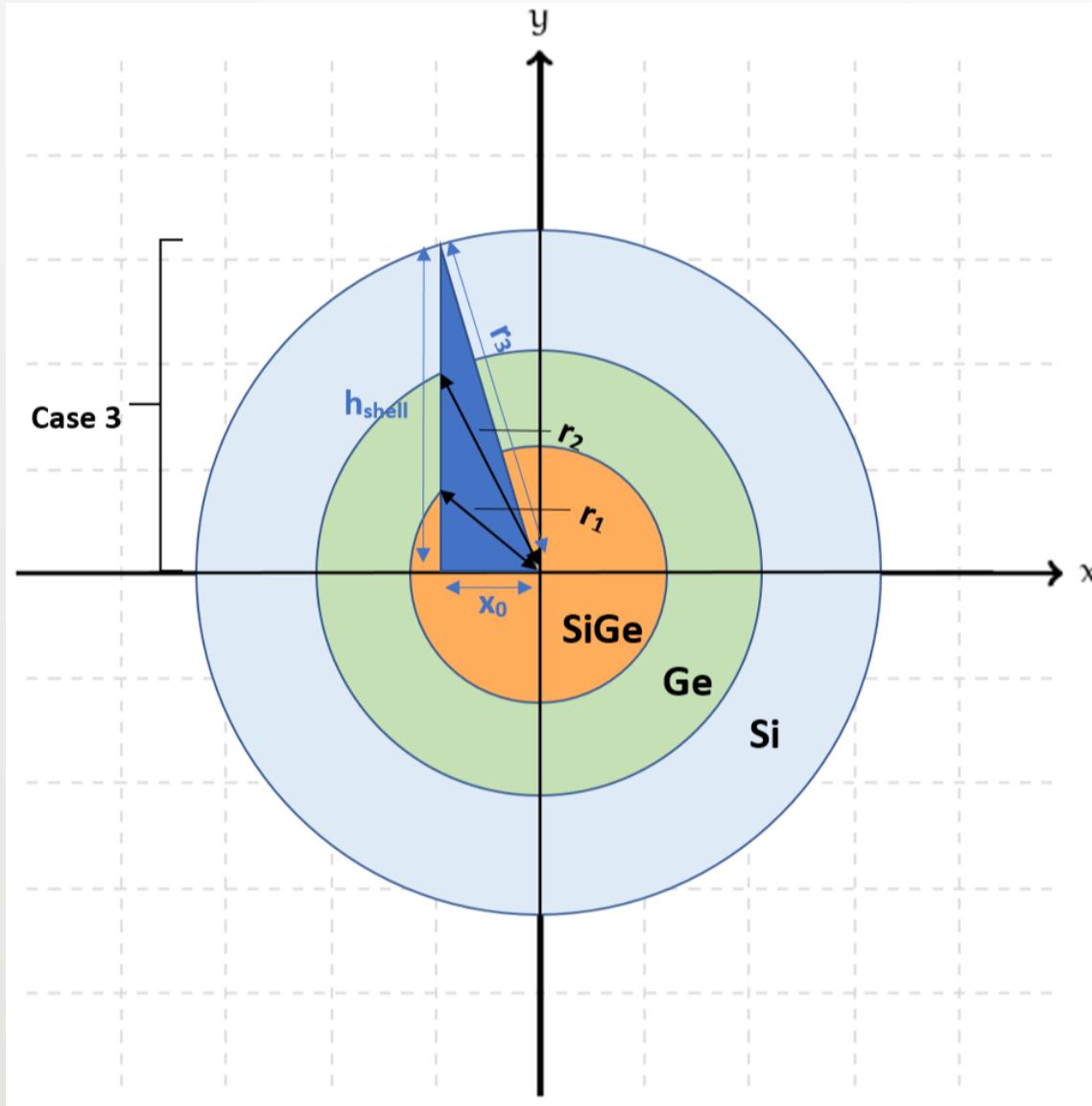
EDX Linescan Across Nanowire



Case 2:
 $|x_0| \geq r_1 \text{ & } |x_0| < r_2$

$$\Psi_{\text{Si}} = 2 * (\sqrt{(r_3^2 - x^2)} - \sqrt{(r_2^2 - x^2)})$$
$$\Psi_{\text{Ge}} = 2 * \sqrt{(r_2^2 - x^2)}$$

EDX Linescan Across Nanowire



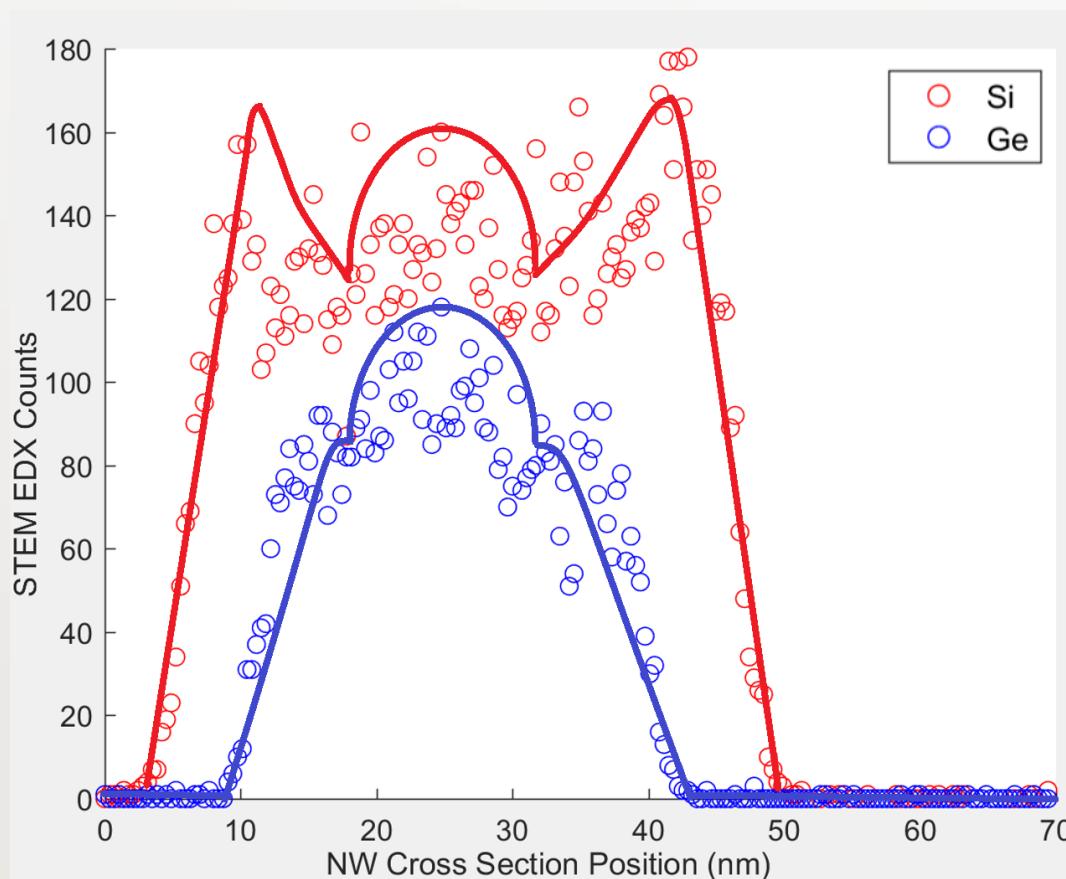
Case 3:

$$|x_0| < r_1$$

$$\Psi_{Si} = 2 * (X_{Si} * (\sqrt{r_1^2 - x^2} + (\sqrt{r_3^2 - x^2} - \sqrt{r_2^2 - x^2})))$$

$$\Psi_{Ge} = 2 * (\sqrt{r_2^2 - x^2} - (\sqrt{r_1^2 - x^2}) + (1 - X_{Si}) \sqrt{r_1^2 - x^2})$$

EDX Linescan Across Nanowire



- Core radius: 18 nm
- Shell 1 thickness: 4 nm
- Shell 2 thickness: 5 nm
- Concentration of Si vs. Ge in shell: 0.5
- E-beam: 1.5
- Center: 70
- Proportionality coefficient: 0.8

MATLAB simulation of EDX data from both Si and Ge K-alpha signals

Future Work

- Build an accurate mathematical model taking actual morphology and beam incident angle to the nanowire
- Quantify and understand strain in NWs using growth parameters (temperature, pressure, gas flow, etc.) in Raman spectroscopy data

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